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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Mun et al.	)	I hereby certify that this paper (or fee) is being
Serial No.: 10/699,438	)	deposited with the United States Postal Service, first class postage prepaid, addressed
Filed: October 31, 2003	)	to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
For: SILICON WAFERS AND METHOD OF FABRICATING THE SAME	) ) )	September 13, 2005
Group Art Unit: 2822	)	
Examiner: Maria F. Guerrero	·) ) ) )	James P. Zeller Reg. No. 28,491

AMENDMENT "A"

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

the amendments to the claims section begins on page 2 of this paper; and the remarks begins on page 6 of this paper.